

**AMENDMENT TRANSMITTAL LETTER**Docket No.
4249-0110PApplication No.
10/602,714-Conf. #9942Filing Date
June 25, 2003Examiner
S. AhmedArt Unit
1765

Applicant(s): Ramam AKKIPEDDI et al.

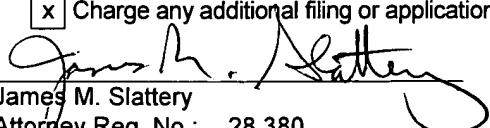
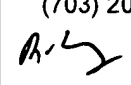
Invention: METHOD OF CLEAVING GaN/SAPPHIRE FOR FORMING LASER MIRROR FACETS

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

| CLAIMS AS AMENDED | | | | | |
|--|---|---|-----------------------------------|------|----------|
| | Claims Remaining After Amendment | Highest Number Previously Paid | Number Extra Claims Present | Rate | |
| Total Claims | 14 | - 20 = | | x | |
| Independent Claims | 1 | - 3 = | | x | |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/> | | | | | |
| Other fee (please specify): Extension for response within third month | | | | | 1,020.00 |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT: | | | | | 1,020.00 |

☒ Large Entity☐ Small Entity☐ No additional fee is required for this amendment.☐ Please charge Deposit Account No. 02-2448 in the amount of \$ _____
A duplicate copy of this sheet is enclosed.☒ A check in the amount of \$ 1,020.00 is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 02-2448
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.
James M. Slattery
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Docket No.: 4249-0110P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ramam AKKIPEDDI et al.

Application No.: 10/602,714

Confirmation No.: 9942

Filed: June 25, 2003

Art Unit: 1765

For: METHOD OF CLEAVING GaN/SAPPHIRE
FOR FORMING LASER MIRROR FACETS

Examiner: S. Ahmed

AMENDMENT UNDER 37 C.F.R. §1.111

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated September 14, 2005, the period for response having been extended by three (3) months until March 14, 2006, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This Amendment contains a substitute abstract, a claim set as amended and remarks.